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Uniform growth of MoS₂ films using ultra-low MoO₃ precursor in one-step heating chemical vapor deposition

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Chemical vapor deposition of clean and pure MoS₂ crystals by the inhibition of MoO₃-x intermediates

Guan, R. , Duan, J. , Yuan, A. (2021) *CrystEngComm*

Cvd synthesis of intermediate state-free, large-area and continuous mos₂ via single-step vapor-phase sulfurization of moo₂ precursor

Chiawchan, T. , Ramamoorthy, H. , Buapan, K. (2021) *Nanomaterials*

Piezoresistive strain sensor based on monolayer molybdenum disulfide continuous film deposited by chemical vapor deposition

Zhu, M. , Sakamoto, K. , Li, J. (2019) *Journal of Micromechanics and Microengineering*

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Abstract

In chemical vapor deposition (CVD), homogeneous molybdenum vapor concentration is important in synthesizing uniform thickness and large coverage of two-dimensional molybdenum disulfide (2D-MoS₂) films. Here, we synthesize few-layer MoS₂ films with uniform thickness and adequate coverage over 50 mm² size area using ultra-low molybdenum trioxide (MoO₃) precursor placed directly under a face-down silicon dioxide/silicon (SiO₂/Si) substrate in one-step heating CVD. The precursor mass is controlled by dispersing MoO₃ powder in ethanol (C₂H₅OH) and varying the volume of MoO₃/C₂H₅OH solution coated on SiO₂/Si substrates into 10, 20 and 25 μL. Field emission scanning electron microscopy images reveal that 20 μL MoO₃/C₂H₅OH solution produces ~93% area coverage of 2D-MoS₂ films. The average Raman spectra show the typical presence of MoS₂ peaks around 378.8 cm⁻¹ and 404 cm⁻¹ referring to the E_{12g} and A_{1g} modes, respectively. The difference between the two Raman modes for all samples is ~25 cm⁻¹, indicating few-layer MoS₂ films. The thickness of MoS₂ films is estimated at around 2.8 ± 0.44 nm and 3.2 ± 0.43 nm (~6 layers) using atomic force microscopy analysis. These findings suggest that ultra-low MoO₃ precursor is useful to produce uniform thickness and high coverage few-layer MoS₂ films using one-step heating CVD. © 2022 Elsevier B.V.

Author keywords

Chemical vapor deposition ; Mo vapor concentration; Molybdenum disulfide; Molybdenum trioxide; One-step heating ; Uniform thickness

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References (50)

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- 1 Singh, A.K., Kumar, P., Late, D.J., Kumar, A., Patel, S., Singh, J.
2D layered transition metal dichalcogenides (MoS₂):
Synthesis, applications and theoretical aspects

(2018) *Applied Materials Today*, 13, pp. 242-270. Cited 68 times.
<http://www.journals.elsevier.com/applied-materials-today/>
doi: 10.1016/j.apmt.2018.09.003

View at Publisher
-
- 2 Samadi, M., Sarikhani, N., Zirak, M., Zhang, H., Zhang, H.-L., Moshfegh, A.Z.
Group 6 transition metal dichalcogenide nanomaterials:
Synthesis, applications and future perspectives

(2018) *Nanoscale Horizons*, 3 (2), pp. 90-204. Cited 200 times.
<http://www.rsc.org/journals-books-databases/about-journals/nanoscale-horizons/?id=8277>
doi: 10.1039/c7nh00137a

View at Publisher
-
- 3 Chhowalla, M., Shin, H.S., Eda, G., Li, L.-J., Loh, K.P., Zhang, H.
The chemistry of two-dimensional layered transition metal
dichalcogenide nanosheets

(2013) *Nature Chemistry*, 5 (4), pp. 263-275. Cited 6571 times.
doi: 10.1038/nchem.1589

View at Publisher
-
- 4 Mak, K.F., Lee, C., Hone, J., Shan, J., Heinz, T.F.
Atomically thin MoS₂: A new direct-gap semiconductor
(Open Access)

(2010) *Physical Review Letters*, 105 (13), art. no. 136805. Cited 10544 times.
http://oai.aps.org/oai?verb=GetRecord&Identifier=oai:aps.org:PhysRevLett.105.136805&metadataPrefix=oai_apsmeta_2
doi: 10.1103/PhysRevLett.105.136805

View at Publisher
-
- 5 Radisavljevic, B., Radenovic, A., Brivio, J., Giacometti, V., Kis, A.
Single-layer MoS₂ transistors (Open Access)

(2011) *Nature Nanotechnology*, 6 (3), pp. 147-150. Cited 10690 times.
<http://www.nature.com/nnano/index.html>
doi: 10.1038/nnano.2010.279

View at Publisher
-
- 6 Wang, Q.H., Kalantar-Zadeh, K., Kis, A., Coleman, J.N., Strano, M.S.
Electronics and optoelectronics of two-dimensional transition
metal dichalcogenides (Open Access)

(2012) *Nature Nanotechnology*, 7 (11), pp. 699-712. Cited 10975 times.
<http://www.nature.com/nnano/index.html>
doi: 10.1038/nnano.2012.193

View at Publisher

- 7 Perkins, F.K., Friedman, A.L., Cobas, E., Campbell, P.M., Jernigan, G.G., Jonker, B.T.
Chemical vapor sensing with monolayer MoS₂
(2013) *Nano Letters*, 13 (2), pp. 668-673. Cited 869 times.
doi: 10.1021/nl3043079
[View at Publisher](#)
-
- 8 Lee, H.S., Min, S.-W., Park, M.K., Lee, Y.T., Jeon, P.J., Kim, J.H., Ryu, S., (...), Im, S.
MoS₂ nanosheets for top-gate nonvolatile memory transistor channel
(2012) *Small*, 8 (20), pp. 3111-3115. Cited 198 times.
[http://onlinelibrary.wiley.com/journal/10.1002/\(ISSN\)1613-6829](http://onlinelibrary.wiley.com/journal/10.1002/(ISSN)1613-6829)
doi: 10.1002/sml.201200752
[View at Publisher](#)
-
- 9 Stephenson, T., Li, Z., Olsen, B., Mitlin, D.
Lithium ion battery applications of molybdenum disulfide (MoS₂) nanocomposites
(2014) *Energy and Environmental Science*, 7 (1), pp. 209-231. Cited 1035 times.
<http://pubs.rsc.org/en/journals/journal/ee>
doi: 10.1039/c3ee42591f
[View at Publisher](#)
-
- 10 Ng, K.E., Ooi, P.C., Shazni Mohammad Haniff, M.A., Goh, B.T., Dee, C.F., Chang, W.S., Razip Wee, M.F.M., (...), Mohamed, M.A.
Performance of all-solution-processed, durable 2D MoS₂ flakes–BaTiO₃ nanoparticles in polyvinylidene fluoride matrix nanogenerator devices using N-methyl-2-pyrrolidone polar solvent
(2020) *Journal of Alloys and Compounds*, 820, art. no. 153160. Cited 16 times.
<https://www.journals.elsevier.com/journal-of-alloys-and-compounds>
doi: 10.1016/j.jallcom.2019.153160
[View at Publisher](#)
-
- 11 Li, H., Wu, J., Yin, Z., Zhang, H.
Preparation and applications of mechanically exfoliated single-layer and multilayer MoS₂ and WSe₂ nanosheets
(2014) *Accounts of Chemical Research*, 47 (4), pp. 1067-1075. Cited 1055 times.
<http://pubs.acs.org/journal/achre4>
doi: 10.1021/ar4002312
[View at Publisher](#)
-
- 12 Magda, G.Z., Pető, J., Dobrik, G., Hwang, C., Biró, L.P., Tapasztó, L.
Exfoliation of large-area transition metal chalcogenide single layers ([Open Access](#))
(2015) *Scientific Reports*, 5, art. no. 14714. Cited 161 times.
www.nature.com/srep/index.html
doi: 10.1038/srep14714
[View at Publisher](#)

- 13 Fan, X., Xu, P., Zhou, D., Sun, Y., Li, Y.C., Nguyen, M.A.T., Terrones, M., (...), Mallouk, T.E.
Fast and Efficient Preparation of Exfoliated 2H MoS₂ Nanosheets by Sonication-Assisted Lithium Intercalation and Infrared Laser-Induced 1T to 2H Phase Reversion
(2015) *Nano Letters*, 15 (9), pp. 5956-5960. Cited 448 times.
<http://pubs.acs.org/journal/nalefd>
doi: 10.1021/acs.nanolett.5b02091
View at Publisher
-
- 14 Zhou, X., Xu, B., Lin, Z., Shu, D., Ma, L.
Hydrothermal synthesis of flower-like MoS₂ nanospheres for electrochemical supercapacitors
(2014) *Journal of Nanoscience and Nanotechnology*, 14 (9), pp. 7250-7254. Cited 92 times.
<http://docserver.ingentaconnect.com/deliver/connect/asp/15334880/v14n9/s107.pdf?expires=1411778238&id=79305185&titleid=4286&accname=Elsevier+BV&checksum=0EAA1B9DD405EFDA4549EDA34B845D42>
doi: 10.1166/jnn.2014.8929
View at Publisher
-
- 15 Lee, Y.-H., Zhang, X.-Q., Zhang, W., Chang, M.-T., Lin, C.-T., Chang, K.-D., Yu, Y.-C., (...), Lin, T.-W.
Synthesis of large-area MoS₂ atomic layers with chemical vapor deposition (Open Access)
(2012) *Advanced Materials*, 24 (17), pp. 2320-2325. Cited 2593 times.
doi: 10.1002/adma.201104798
View at Publisher
-
- 16 Liu, K.-K., Zhang, W., Lee, Y.-H., Lin, Y.-C., Chang, M.-T., Su, C.-Y., Chang, C.-S., (...), Li, L.-J.
Growth of large-area and highly crystalline MoS₂ thin layers on insulating substrates (Open Access)
(2012) *Nano Letters*, 12 (3), pp. 1538-1544. Cited 1548 times.
doi: 10.1021/nl2043612
View at Publisher
-
- 17 Zhan, Y., Liu, Z., Najmaei, S., Ajayan, P.M., Lou, J.
Large-area vapor-phase growth and characterization of MoS₂ atomic layers on a SiO₂ substrate (Open Access)
(2012) *Small*, 8 (7), pp. 966-971. Cited 1414 times.
doi: 10.1002/smll.201102654
View at Publisher
-
- 18 Johari, M.H., Sirat, M.S., Mohamed, M.A., Wakayama, Y., Mohamad, A.R.
Effects of post-annealing on MoS₂ thin films synthesized by multi-step chemical vapor deposition (Open Access)
(2021) *Nanomaterials and Nanotechnology*, 11. Cited 3 times.
<http://nax.sagepub.com/content/by/year>
doi: 10.1177/1847980420981537
View at Publisher

- 19 Fauzi, F.B., Ismail, E., Syed Abu Bakar, S.N., Ismail, A.F., Mohamed, M.A., Md Din, M.F., Illias, S., (...), Ani, M.H.

The role of gas-phase dynamics in interfacial phenomena during few-layer graphene growth through atmospheric pressure chemical vapour deposition ([Open Access](#))

(2020) *Physical Chemistry Chemical Physics*, 22 (6), pp. 3481-3489. Cited 6 times.

<http://pubs.rsc.org/en/journals/journal/cp>
doi: 10.1039/c9cp05346h

[View at Publisher](#)

- 20 Najmaei, S., Liu, Z., Zhou, W., Zou, X., Shi, G., Lei, S., Yakobson, B.I., (...), Lou, J.

Vapour phase growth and grain boundary structure of molybdenum disulphide atomic layers ([Open Access](#))

(2013) *Nature Materials*, 12 (8), pp. 754-759. Cited 1384 times.

<http://www.nature.com/nmat/>
doi: 10.1038/nmat3673

[View at Publisher](#)

- 21 The Merck Index
(1983) . Cited 5120 times.
10th Edition Merck Co., Inc. Rahway, New Jersey 10th ed.

- 22 Lide, D.R.
CRC Handbook of Chemistry and Physics 88th 2007-2008
(2007) . Cited 59909 times.
88th ed. CRC Press, Taylor & Francis Boca Raton, FL

- 23 Jian, J., Chang, H., Xu, T.
Structure and properties of single-layer MoS₂ for nano-photoelectric devices ([Open Access](#))

(2019) *Materials*, 12 (2), art. no. 198. Cited 14 times.

<https://www.mdpi.com/1996-1944/12/2/198/pdf>
doi: 10.3390/ma12020198

[View at Publisher](#)

- 24 Wang, W., Zeng, X., Wu, S., Zeng, Y., Hu, Y., Ding, J., Xu, S.
Effect of Mo concentration on shape and size of monolayer MoS₂ crystals by chemical vapor deposition

(2017) *Journal of Physics D: Applied Physics*, 50 (39), art. no. 395501. Cited 12 times.

<http://iopscience.iop.org/article/10.1088/1361-6463/aa81ae/pdf>
doi: 10.1088/1361-6463/aa81ae

[View at Publisher](#)

- 25 Johari, M.H., Sirat, M.S., Mohamed, M.A., Mohd Nasir, S.N.F., Mat Teridi, M.A., Mohmad, A.R.
Effects of Mo vapor concentration on the morphology of vertically standing MoS₂ nanoflakes
(2020) *Nanotechnology*, 31 (30), art. no. 305710. Cited 7 times.
<https://iopscience.iop.org/article/10.1088/1361-6528/ab8666>
doi: 10.1088/1361-6528/ab8666
View at Publisher
-
- 26 Nikpay, M.A., Mortazavi, S.Z., Reyhani, A., Elahi, S.M.
The effect of carrier gas flow rate on the growth of MoS₂ nanoflakes prepared by thermal chemical vapor deposition
(2018) *Optical and Quantum Electronics*, 50 (6), art. no. 252. Cited 3 times.
<https://rd.springer.com/journal/11082>
doi: 10.1007/s11082-018-1512-2
View at Publisher
-
- 27 Liu, H., Zhu, Y., Meng, Q., Lu, X., Kong, S., Huang, Z., Jiang, P., (...), Bao, X.
Role of the carrier gas flow rate in monolayer MoS₂ growth by modified chemical vapor deposition
(2017) *Nano Research*, 10 (2), pp. 643-651. Cited 31 times.
<http://www.springer.com/materials/nanotechnology/journal/12274>
doi: 10.1007/s12274-016-1323-3
View at Publisher
-
- 28 Rosman, N.N., Mohamad Yunus, R., Jeffery Minggu, L., Arifin, K., Kassim, M.B., Mohamed, M.A.
Vertical MoS₂ on SiO₂/Si and graphene: Effect of surface morphology on photoelectrochemical properties
(2021) *Nanotechnology*, 32 (3), art. no. 035705. Cited 8 times.
<https://iopscience.iop.org/article/10.1088/1361-6528/abbea9>
doi: 10.1088/1361-6528/abbea9
View at Publisher
-
- 29 Lin, Z., Zhao, Y., Zhou, C., Zhong, R., Wang, X., Tsang, Y.H., Chai, Y.
Controllable Growth of Large-Size Crystalline MoS₂ and Resist-Free Transfer Assisted with a Cu Thin Film (Open Access)
(2015) *Scientific Reports*, 5, art. no. 18596. Cited 136 times.
www.nature.com/srep/index.html
doi: 10.1038/srep18596
View at Publisher
-
- 30 Withanage, S.S., Kalita, H., Chung, H.-S., Roy, T., Jung, Y., Khondaker, S.I.
Uniform Vapor-Pressure-Based Chemical Vapor Deposition Growth of MoS₂ Using MoO₃ Thin Film as a Precursor for Coevaporation (Open Access)
(2018) *ACS Omega*, 3 (12), pp. 18943-18949. Cited 17 times.
pubs.acs.org/journal/acsodf
doi: 10.1021/acsomega.8b02978
View at Publisher

- 31 Deng, S., Che, S., Debbarma, R., Berry, V.
Strain in a single wrinkle on an MoS₂ flake for in-plane realignment of band structure for enhanced photo-response
(2019) *Nanoscale*, 11 (2), pp. 504-511. Cited 17 times.
<http://pubs.rsc.org/en/journals/journal/nr>
doi: 10.1039/c8nr05884a
View at Publisher
-
- 32 Kim, S.J., Kim, D.W., Lim, J., Cho, S.-Y., Kim, S.O., Jung, H.-T.
Large-Area Buckled MoS₂ Films on the Graphene Substrate
(2016) *ACS Applied Materials and Interfaces*, 8 (21), pp. 13512-13519. Cited 33 times.
<http://pubs.acs.org/journal/aamick>
doi: 10.1021/acsami.6b01828
View at Publisher
-
- 33 Luo, S., Hao, G., Fan, Y., Kou, L., He, C., Qi, X., Tang, C., (...), Zhong, J.
Formation of ripples in atomically thin MoS₂ and local strain engineering of electrostatic properties
(2015) *Nanotechnology*, 26 (10), art. no. 105705. Cited 68 times.
http://iopscience.iop.org/0957-4484/26/10/105705/pdf/0957-4484_26_10_105705.pdf
doi: 10.1088/0957-4484/26/10/105705
View at Publisher
-
- 34 Zhou, D., Shu, H., Hu, C., Jiang, L., Liang, P., Chen, X.
Unveiling the Growth Mechanism of MoS₂ with Chemical Vapor Deposition: From Two-Dimensional Planar Nucleation to Self-Seeding Nucleation
(2018) *Crystal Growth and Design*, 18 (2), pp. 1012-1019. Cited 53 times.
<http://pubs.acs.org/journal/cgdefu>
doi: 10.1021/acs.cgd.7b01486
View at Publisher
-
- 35 Cain, J.D., Shi, F., Wu, J., Dravid, V.P.
Growth Mechanism of Transition Metal Dichalcogenide Monolayers: The Role of Self-Seeding Fullerene Nuclei
(2016) *ACS Nano*, 10 (5), pp. 5440-5445. Cited 128 times.
<http://pubs.acs.org/journal/ancac3>
doi: 10.1021/acs.nano.6b01705
View at Publisher
-
- 36 Pondick, J.V., Woods, J.M., Xing, J., Zhou, Y., Cha, J.J.
Stepwise Sulfurization from MoO₃ to MoS₂ via Chemical Vapor Deposition
(2018) *ACS Applied Nano Materials*, 1 (10), pp. 5655-5661. Cited 49 times.
<https://pubs.acs.org/journal/aanmf6>
doi: 10.1021/acsanm.8b01266
View at Publisher

- 37 Molina-Sánchez, A., Wirtz, L.
Phonons in single-layer and few-layer MoS₂ and WS₂
([Open Access](#))
- (2011) *Physical Review B - Condensed Matter and Materials Physics*, 84 (15), art. no. 155413. Cited 1019 times.
<http://oai.aps.org/filefetch?identifier=10.1103/PhysRevB.84.155413&component=fulltext&description=markup&format=xml>
doi: 10.1103/PhysRevB.84.155413
- [View at Publisher](#)
-
- 38 Lee, C., Yan, H., Brus, L.E., Heinz, T.F., Hone, J., Ryu, S.
Anomalous lattice vibrations of single- and few-layer MoS₂
([Open Access](#))
- (2010) *ACS Nano*, 4 (5), pp. 2695-2700. Cited 3350 times.
doi: 10.1021/nn1003937
- [View at Publisher](#)
-
- 39 Wang, S., Pacios, M., Bhaskaran, H., Warner, J.H.
Substrate control for large area continuous films of monolayer MoS₂ by atmospheric pressure chemical vapor deposition
- (2016) *Nanotechnology*, 27 (8), art. no. 085604. Cited 67 times.
<http://iopscience.iop.org/article/10.1088/0957-4484/27/8/085604/pdf>
doi: 10.1088/0957-4484/27/8/085604
- [View at Publisher](#)
-
- 40 Li, H., Zhang, Q., Yap, C.C.R., Tay, B.K., Edwin, T.H.T., Olivier, A., Baillargeat, D.
From bulk to monolayer MoS₂: Evolution of Raman scattering
- (2012) *Advanced Functional Materials*, 22 (7), pp. 1385-1390. Cited 2727 times.
doi: 10.1002/adfm.201102111
- [View at Publisher](#)
-
- 41 Placidi, M., Dimitrievska, M., Izquierdo-Roca, V., Fontané, X., Castellanos-Gomez, A., Pérez-Tomás, A., Mestres, N., (...), Pérez-Rodríguez, A.
Multiwavelength excitation Raman scattering analysis of bulk and two-dimensional MoS₂: Vibrational properties of atomically thin MoS₂ layers ([Open Access](#))
- (2015) *2D Materials*, 2 (3), art. no. 035006. Cited 72 times.
<http://iopscience.iop.org/2053-1583/>
doi: 10.1088/2053-1583/2/3/035006
- [View at Publisher](#)
-
- 42 Tan, S.M., Ambrosi, A., Pumera, M.
(2015), pp. 7170-7178.
Pristine Basal- and Edge-Plane-Oriented Molybdenite MoS₂ Exhibiting Highly Anisotropic Properties

- 43 Chen, F., Su, W.
The effect of the experimental parameters on the growth of MoS₂ flakes
(2018) *CrystEngComm*, 20 (33), pp. 4823-4830. Cited 16 times.
<http://pubs.rsc.org/en/journals/journal/ce>
doi: 10.1039/c8ce00733k
View at Publisher
-
- 44 Shi, Y., Zhang, H., Chang, W.-H., Shin, H.S., Li, L.-J.
Synthesis and structure of two-dimensional transition-metal dichalcogenides (Open Access)
(2015) *MRS Bulletin*, 40 (7), pp. 566-576. Cited 30 times.
<http://journals.cambridge.org/MRS>
doi: 10.1557/mrs.2015.121
View at Publisher
-
- 45 Addou, R., Colombo, L., Wallace, R.M.
Surface Defects on Natural MoS₂
(2015) *ACS Applied Materials and Interfaces*, 7 (22), pp. 11921-11929. Cited 235 times.
<http://pubs.acs.org/journal/aamick>
doi: 10.1021/acsami.5b01778
View at Publisher
-
- 46 Zhu, Z., Zhan, S., Zhang, J., Jiang, G., Yi, M., Wen, J.
Influence of growth temperature on MoS₂ synthesis by chemical vapor deposition
(2019) *Materials Research Express*, 6 (9), art. no. 095011. Cited 6 times.
<https://iopscience.iop.org/article/10.1088/2053-1591/ab2c19/pdf>
doi: 10.1088/2053-1591/ab2c19
View at Publisher
-
- 47 Yin, H., Zhang, X., Lu, J., Geng, X., Wan, Y., Wu, M., Yang, P.
Substrate effects on the CVD growth of MoS₂ and WS₂
(2020) *Journal of Materials Science*, 55 (3), pp. 990-996. Cited 24 times.
www.springer.com/journal/10853
doi: 10.1007/s10853-019-03993-9
View at Publisher
-
- 48 Jo, S., Jung, J.-W., Baik, J., Kang, J.-W., Park, I.-K., Bae, T.-S., Chung, H.-S., (...), Cho, C.-H.
Surface-diffusion-limited growth of atomically thin WS₂ crystals from core-shell nuclei (Open Access)
(2019) *Nanoscale*, 11 (18), pp. 8706-8714. Cited 11 times.
<http://pubs.rsc.org/en/journals/journal/nr>
doi: 10.1039/c9nr01594a
View at Publisher

- 49 Withanage, S.S., Khondaker, S.I.
CVD Growth of Monolayer MoS₂ on Sapphire Substrates by
using MoO₃ Thin Films as a Precursor for Co-Evaporation

(2019) *MRS Advances*, 4 (10), pp. 587-592. Cited 5 times.
<https://www.cambridge.org/core/journals/mrs-advances>
doi: 10.1557/adv.2018.657

[View at Publisher](#)

- 50 Ardahe, M., Hantehzadeh, M.R., Ghoranneviss, M.
Effect of Growth Temperature on Physical Properties of MoS₂
Thin Films Synthesized by CVD

(2020) *Journal of Electronic Materials*, 49 (2), pp. 1002-1008. Cited 9 times.
<https://rd.springer.com/journal/11664>
doi: 10.1007/s11664-019-07796-1

[View at Publisher](#)

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